



**ELECTRONIC COPY**

LG803683320  
Report verification at igi.org



May 29, 2026  
IGI Report Number **LG803683320**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **11.57 X 8.43 X 5.06 MM**  
**GRADING RESULTS**  
Carat Weight **3.08 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**

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**GRADING RESULTS**

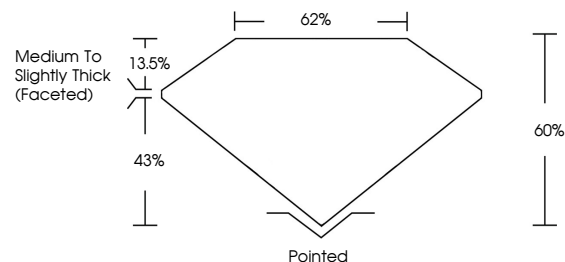
Carat Weight **3.08 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG803683320**

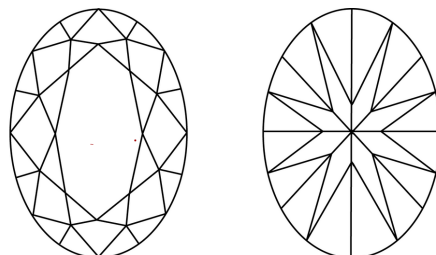
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

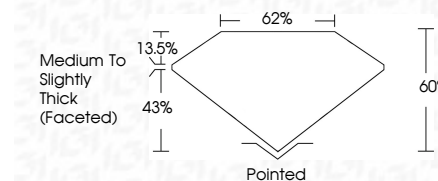
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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**OVAL BRILLIANT**  
3.08 CARATS  
E  
11.57 X 8.43 X 5.06 MM  
Color Grade  
Clarity Grade  
Table  
Depth  
Girdle  
Medium to Slightly Thick (Faceted)  
Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG803683320  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa